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AP20 Rec'd PCT/PTO 05 JUL 2006

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasushi NOGUCHI et al.

New U.S. National Phase of PCT/JP2005/000169

Filed: July 5, 2006 Docket No.: 128634

For: METHOD FOR MANUFACTURING CERAMIC STRUCTURE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. Relevance of one or more non-English language reference is discussed in the present specification. See References 8 & 9.
- 3. One or more reference cited herein was cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information. See References 2-7.
- 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- 5. An English language Abstract of one or more non-English language reference is attached hereto. See References <u>2-9</u>.
- 6. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 2, 5, 8 & 9.

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7. References 1, 4 & 7 correspond to references 6, 2 & 5 respectively.

Respectfully submitted,

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JAO:WPB/jdb

Date: July 5, 2006

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(Use several sheets if necessary)				APPLICANTS Yasushi NOGUCHI et al.				
				FILING DATE July 5, 2006				
U.S. PATENT DOCUMENTS								
Examiner Initials	Cite No.	Document Number	Date 5/13/2004 .		N	lame		
	1	2004/0091709			Ohmura et al.			
								
			<u> </u>					
		FORE	IGN PATI	ENT DOC	UMENTS			
Examiner Initials	Cite No.	Document Number	Da	ite	Country	With English Abstract	With English Translation	
·	2	JP A 2004-000901	1/8/2004		Japan	x	X	
	3	JP A 62-286534	12/12/1987		Japan	x		
	4	WO 03/082437	10/9/2003		WIPO	x		
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	6	WO 02/072671	9/19/2002		Japan	x		
	7	WO 03/004132	1/16/2003		WIPO	х		
	8	JP A 09-077573	3/25/199	7	Japan ,	x	Х	
	9	JP A 2002-326879	11/12/20	002	Japan	X	Х	
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